

Applicant:	Lucimara ROMAN et al.	Conf.:	9297
Appl. No.:	09/720,329	Group:	2818
Filed:	February 6, 2001	Examiner:	David Vu
For:	A METHOD IN FABRICATION OF ORGANIC THIN FILM SEMICONDUCTOR SERVICES		

LARGE ENTITY TRANSMITTAL FORM

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 18, 2003

Sir:

Transmitted herewith is an amendment in the above-identified application.

- ☐ The enclosed document is being transmitted via the Certificate of Mailing provisions of 37 C.F.R. § 1.8.
- ☐ The enclosed document is being transmitted via facsimile.

The fee has been calculated as shown below:

	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR		PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL	8	-	20	=	0	\$ 18	\$0.00
INDEPENDENT	1	-	3	=	0	\$ 86	\$0.00
<input type="checkbox"/> FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM						\$290	\$0.00
						TOTAL	\$0.00

- ☒ Petition for three (3) month(s) extension of time pursuant to 37 C.F.R. §§ 1.17 and 1.136(a). \$950.00 for the extension of time.
- ☐ No fee is required.
- ☒ Check(s) in the amount of \$950.00 is being paid concurrently with the Notice of Appeal.
- ☐ Please charge Deposit Account No. 02-2448 in the amount of \$0.00. This form is submitted in triplicate.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. § 1.16 or under 37 C.F.R. § 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

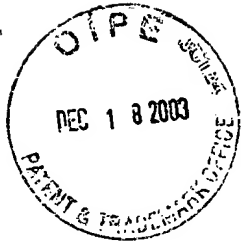
By maas
MaryAnne Armstrong, Ph.D. #40,069

MKM/MAA/jmb
3672-0110P

P.O. Box 747
Falls Church, VA 22040-0747
(703) 205-8000

Attachment(s)

(Rev. 09/30/03)



MS AF
REPLY UNDER
37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2818

PATENT
3672-0110P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: ROMAN, Lucimara S. et al. Conf.: 9297
Appl. No.: 09/720,329 Group: 2818
Filed: February 6, 2001 Examiner: Vu, David

For: A METHOD IN FABRICATION OF ORGANIC THIN
FILM SEMICONDUCTING SERVICES

REPLY AFTER FINAL UNDER 37 C.F.R. § 1.116

MS AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 18, 2003

Sir:

In reply to the Office Action dated June 18, 2003 and in response to the Advisory Action of October 22, 2003, the due date having been extended for three (3) months to December 18, 2003, the following remarks are respectfully submitted in connection with the above-identified application.

This reply includes amendments to the specification and drawings and remarks.